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A facile process to manufacture high performance copper layer on ceramic material via biomimetic modification and electroless plating

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2	material via biomimetic modification and electroless plating
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7	Abstract:
8	A convenient and eco-friendly approach to fabricate high-quality copper layer on ceramic
9	viasurface modification combined with electroless plating is introduced in thispaper. Through the
10	surface modification of polydopamine, alumina ceramic substrate is capable of adsorbing silver
11	ions, which could create an activating layer to catalyze the subsequent electrolesscopper plating
12	(ECP) at low temperature. The finding that modificationcould obviously enhance the adhesion
13	betweensubstrates and copper layers are evaluated by water contact angle measurement, XPS,
14	FT-IR, SEM, EDS and adhesion tests. Moreover, after30 min of ECP, the resulting deposited
15	copper layer presents an excellent performance in adhesion (highest level in ASTM D3359)
16	and conduction (up to $4.2 \times 10^7 \text{S} \cdot \text{m}^{-1}$, nearly 70 per cent of bulk copper). This technology might
17	provide a potential way to realize surface metallization on ceramicsubstrates applied in electronic
18	circuits and devices.
10	<i>V</i>

19

20 Keywords: ceramic; polydopamine; surface modification; electroless copper plating; adhesion.

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